

JG00143 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Yu et al.

Date: 7 January 2003

Serial No.: 09/842,734

Group Art Unit: 2811

Filed: 26 April 2001

Examiner: S. Hu

For:

STRUCTURE AND METHOD FOR FABRICATING SEMICONDUCTOR STRUCTURES AND DEVICES USING BINARY METAL OXIDE LAYERS

CERTIFICATION OF FACSIMILE TRANSMISSION

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING FACSIMILE. TRANSMITTED TO THE UNITED STATES PATENT AND TRADEMARK OFFICE ON THE DATE SHOWN BELOW.

Name of Person Signing Certification

FAX RECEIVED

RESPONSE TO RESTRICTION REQUIREMENT

JAN 7 - 2003

TECHNOLOGY CENTER 2800

Honorable Commissioner of Patents and Trademarks, Washington, D.C. 20231

SIR:

In response to the Office Action dated 9 December 2002, please consider the remarks for the above identified application as follows:

REMARKS

The claims in this Application was previously restricted to claims 1-38.

This response is to the Office Action requiring the election of a species from one of six identified by the Examiner.